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독일 LEICA DVM6총판 및 3D Profiler 대리점



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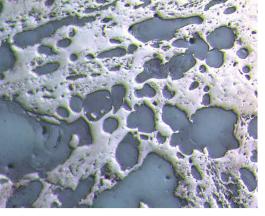


SHINE A NEW LIGHT ON INDUSTRIAL SAMPLES

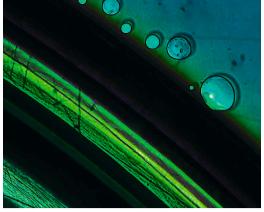
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The DM750 M





Polished light metal, reflected light, brightfield-oblique contrast



DVD, reflected light, brightfield, crossed polarizer

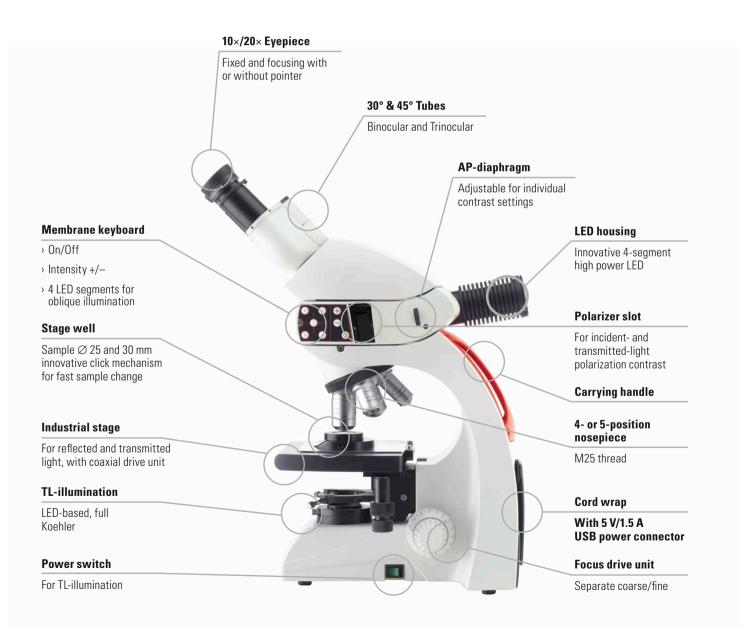


Polished metal sample, reflected light, brightfield



SIMPLY MICROSCOPY FOR ROUTINE TASKS IN MATERIALS QC AND TEACHING

An easy-to-use microscope makes a laboratory function more efficiently. The user can concentrate on the task at hand rather than on complex microscope functions. The Leica DM750 M is an entry-level materials microscope for brightfield, oblique, and polarized light. It is specifically designed to serve the needs of routine quality control and materials analysis in industry as well as the general educational needs in universities, and technical colleges.



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PERFORMANCE RELOADED

The Leica DM750 M combines numerous innovative features to create a unique solution for routine applications in metallography and general materials microscopy.

REFLECTED LIGHT ILLUMINATOR WITH CUTTING-EDGE LED ILLUMINATION

- Built-in adjustable aperture diaphragm, produces bright and crisp lighting for all samples
- > Ergonomically-positioned membrane-keyboard for easy, intuitive operation of all reflected light settings
- Innovative 4-segment LED provides bright and homogeneous
 BF and oblique illumination (quarter / half, direction selectable)
- Intuitive control for LED-light intensity

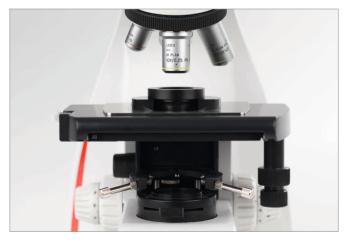
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- Power on/off switch distinctly separated from other keys to avoid operating errors
- Reflected light illuminator incorporates two slots that allows the use of a polarizer and analyzer for polarized light applications
- Power to the LED reflected light illuminator is provided via a USB cable from the 5 V/1.5 A USB power connector on the rear of the Leica DM750 M stand. This saves the cost of an external power supply plus reduces the complexity at the workstation.

ILLUMINATION OPTIONS

- LED illumination is used for reflected and transmitted light. It provides cool, white light with a lifetime of over 20 years, thus saving the time and money spent to exchange halogen bulbs on conventional microscopes
- Transmitted light Koehler field diaphragm for optimum illumination and contrast
- > Optional condensor available
- Patented time delay shutoff saves energy by automatically turning off the illumination after two hours of no use (TL only).







UP TO 1,000×

- High precision 4- or 5-position objective nosepiece with M25 thread
- Large selection of high performance objectives starting with HI PLAN EPI series
- Standard magnification range between 50× and 500× as required by most industrial standards
- > Even higher magnifications, e.g. 1,000×, are possible



EASY SAMPLE HANDLING

- Universal stage with coaxial drive for reflected and transmitted light applications allows observation of polished and/or etched samples with heights of up to 30 mm
- Special sample holders with a 25 mm or 30 mm sample diameters
- › Object guide for precise X/Y positioning of the sample



EASY AND ERGONOMIC OPERATION

- > 4- or 5-position nosepiece with rubber covered knurled ring for fast and easy change of objective magnification. The highly accurate machining of the nosepieces ensures parcentration of all objectives in use.
- > 4 different tubes to fit the ergonomic needs of different users:
 45° angle binocular or trinocular tube or, 30° angle binocular or trinocular tube
- All tubes have adjustable interpupillary distance and locking mechanisms for the eyepieces, avoiding loss / theft of equipment.
- The eyepieces with magnification factor 10 and FOV 20 are available as fixed and focusable to compensate different vision requirements for defective eyesight.

BRILLIANT VIEWS WITH HD IMAGING

The ability to capture, analyze, archive, and share micro-images has always been an important task in the materials laboratory. Leica Microsystems offers an extensive range of advanced digital imaging solutions to exactly match camera and software performance to the needs of your specific application.

LEICA MICROSYSTEMS IMAGING

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- A large variety of Leica microscope cameras including full HD live image. Leica cameras provide high resolution pictures and fast live images.
- Leica software is the modular platform for easy camera control, image capture, annotation, measurement, and documentation.
- Customize your own imaging solution using a wide selection of optional software modules.
- > Store and recall: for instantly perfect results for all samples

- Expert modules for easy-to-use grainsizing and phase analysis according to international norms and standards.
- The modular design of the system allows easy upgrades and service.
- Trinocular viewing tubes and C-mount adapters provide the versatility to use stand-alone cameras, which opens the door to unlimited imaging possibilities.



Copper-zinc deformation line

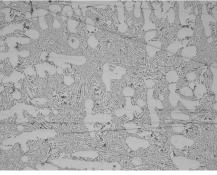




Grain sizing reticle overlay



Polished section of rock

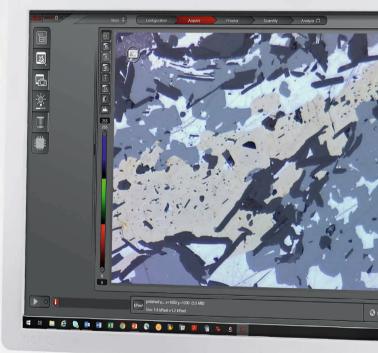


Weld structure, brightfield

Brass sample, brightfield









SPECIFICATIONS

STAND

Shape of the stand protects controls	
Stand construction – die-cast aluminum	
Adjustable Koehler field diaphragm (TL)	
Centerable and focusable condenser mount	
External fuses	
Knurled nosepieces	
5 V/1.5 A USB power supply	
REFLECTED LIGHT AXIS	
4-segment LED illumination for:	
Incident light brightfield	
Oblique contrast	
Polarization contrast	
Built-in adjustable aperture diaphragm	
Removable beam splitter to avoid false pleochroism	
MEMBRANE KEYBOARD CONTROL	
3 LED segment control for selection and rotation of illumination direction	
LED-light intensity	
Power on/off switch	
POLARIZER/ANALYZER SLOT FOR POLARIZED LIGHT	
TRANSMITTED LIGHT	
Built-in LED illumination – 25.000 hours service lifetime	
Full Koehler field diaphragm (with condensor)	
Optional Abba condensor (NA 0.9)	

Full Koehler field diaphragm (with condensor) Optional Abbe condensor (NA 0.9) Continuous intensity adjustment 2 hours auto off (can be disabled or enabled)

EYEPIECES

High eyepoint	
10×/20 (20 mm field of view)	
Crosshair eyepiece with 45° marks, scale, and orientation feature	
Available fixed or focusing	
Focusing eyepieces with reticule holder for 24.5 mm reticule	
Foldable eyeguards	
30 mm mounting diameter	
Other eyepiece magnification factors also available	

Integrate	d coaxial drive for X/Y movement
Stage su	rface 185 mm (150 mm front) × 140 mm (W × D)
Stages p	repared to take special sample holders (stage wells)
Rounded	stage edges
Non-exte	ending rack
Vernier fo	or X/Y coordinates
Wear-res	istant stage surface
	L SAMPLE HOLDERS FOR EMBEDDED METALLOGRAPHIC SALES WELLS)
Stage we	Il for one inch samples
Stage we	ell for maximum sample height = 30 mm
OBJECT	IVES
Infinity p	latform
	or N PLAN series
Objective	a labeling laser engraved
	epiece thread
FOCUS	
Low posi	tion focus controls
Self-adju	sting focus mechanism
300 micro	ons per fine focus rotation
Calibrate	d in 3 micron increments
Weighte	d focus knobs
IMAGIN	G
Trinocula	r tubes available (50% / 50% light split)
C-mount	adapters with standard Leica Microsystems mount
Leica car	neras
EZSTOR	Етм
Vertical ł	nandle
Undercut	in front of stand
Cord wra	p
Vertical o	cord attachment to stand
AGTRE/	Ттм
Anti-mici	robial surfaces
CERTIFI	CATIONS

cULus, CE, RoHS

RECOMMENDED OUTFITS

Leica DM750 M with 4-position nosepiece for reflected & oblique light including industrial stage & stage wells

STAND		Quantity
13 613 115	Leica DM750 M with 4-position nosepiece	1
TUBES		
13 613 521	30° binocular tube	1
EYEPIECES	5	
13 613 532	10×/20 focusing eyepiece with eyeguard	1
13 613 530	10×/20 eyepiece with eyeguard	1

ILLUMINATION

13 613 171	Incident light axis with LED illumination	1

STAGE WELL PLATES

13 613 167	Stage well for small diameter samples	1
13 613 168	Stage well for large diameter samples	1

OBJECTIVES

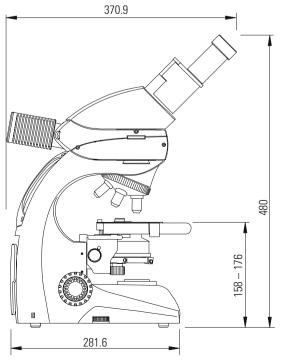
11 566 071	Objective HI PLAN EPI 5×/0.12	1
11 566 069	Objective HI PLAN EPI 10×/0.25	1
11 566 070	Objective HI PLAN EPI 20×/0.40	1
11 566 072	Objective N PLAN EPI 50×/0.75	1

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POWER CORD NOT INCLUDED: Must be ordered separately

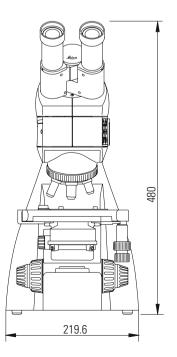
DIMENSIONS

Dimensions in mm



Leica DM750 M with 5-position nosepiece for RL, TL, oblique & polarized light including industrial stage & stage wells, Leica DMC2900

STAND		Quantity
13 613 117	Leica DM750 M with 5-position nosepiece & industrial stage (right hand)	1
TUBES / M	OUNT / CAMERA	
13 613 523	30° Trinocular tube	1
13 613 706	C-mount 0.55×	1
12 730 466	Leica DMC2900 camera	1
EYEPIECES	3	
13 613 532	10×/20 focusing eyepiece with eyeguard	1
13 613 530	10×/20 eyepiece with eyeguard	1
ILLUMINA	TION	
13 613 172	Reflected light illuminator kit LED (RL-Axis, polarizer & analyzer)	1
STAGE WE	LL PLATES	
13 613 167	Stage well for small diameter samples	1
13 613 168	Stage well for large diameter samples	1
13 613 550	Abbe condensor	1
OBJECTIV	ES	
11 566 071	Objective HI PLAN EPI 5×/0.12	1
11 566 069	Objective HI PLAN EPI 10×/0.25	1
11 566 070	Objective HI PLAN EPI 20×/0.40	1
11 566 072	Objective N PLAN EPI 50×/0.75	1
11 566 073	Objective N PLAN EPI 100×/0.75	1
POWER CO	IRD NOT INCLUDED: Must be ordered separately	1



SYSTEM DIAGRAM

